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SERIAL NUMBER 10/642,657	FILING DATE 08/19/2003 RULE	CLASS 430	GROUP ART UNIT 1756	ATTORNEY DOCKET NO. Q77049
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APPLICANTS

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** CONTINUING DATA *****
None, JSR

** FOREIGN APPLICATIONS *****
 JAPAN 238576/2002 08/19/2002 - *JSR*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 14	INDEPENDENT CLAIMS 5
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Verified and Acknowledged
 Examiner's Signature *JSR* Initials

ADDRESS
 23373
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TITLE
 Method of producing a glass substrate for a mask blank, method of producing a mask blank, method of producing a transfer mask, method of producing a semiconductor device, glass substrate for a mask blank, mask blank, and transfer mask

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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